

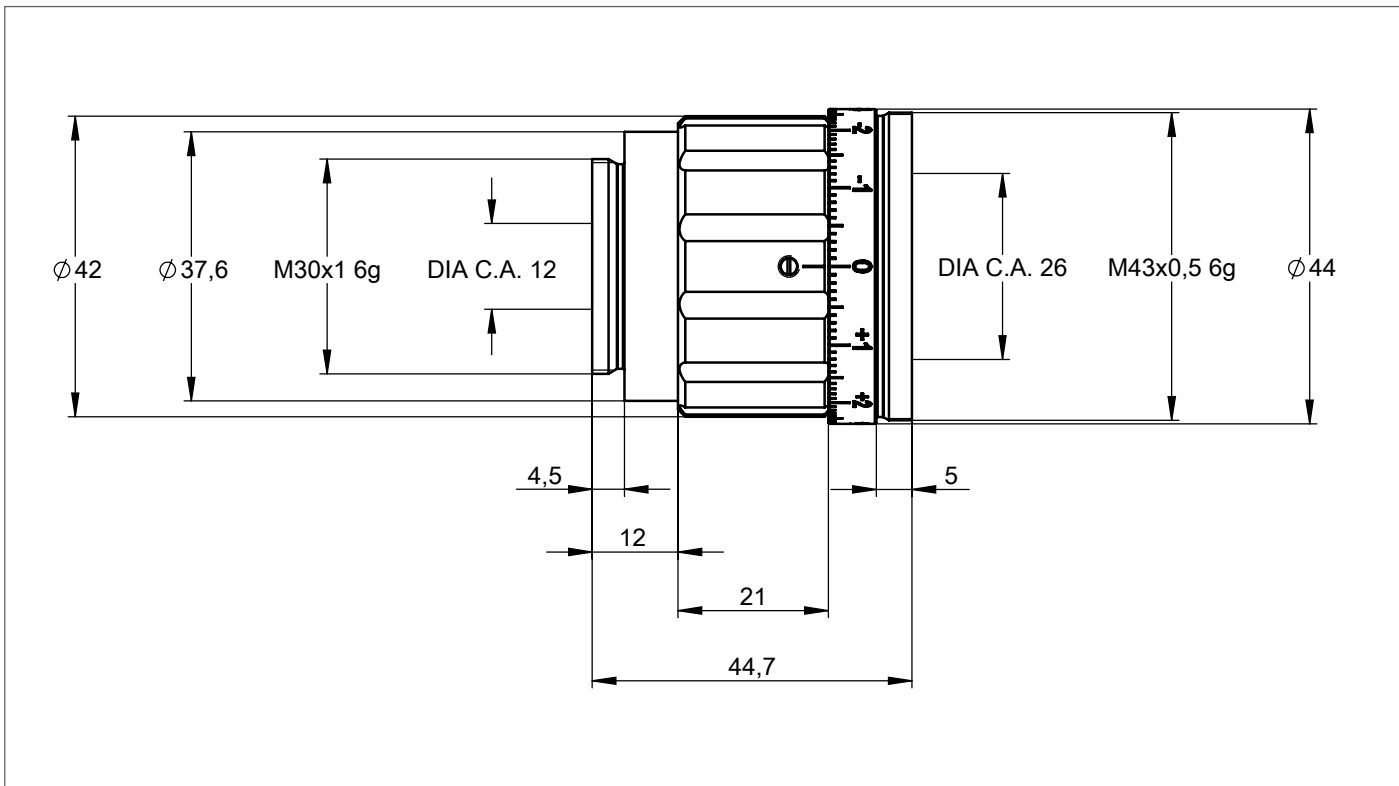
DATA SHEET

S6EXK0020-328

BEAMEXPANDER
MAGNIFICATION 2.0
FOR 1030 - 1090 nm
FUSED SILICA



OUTLINE DRAWING



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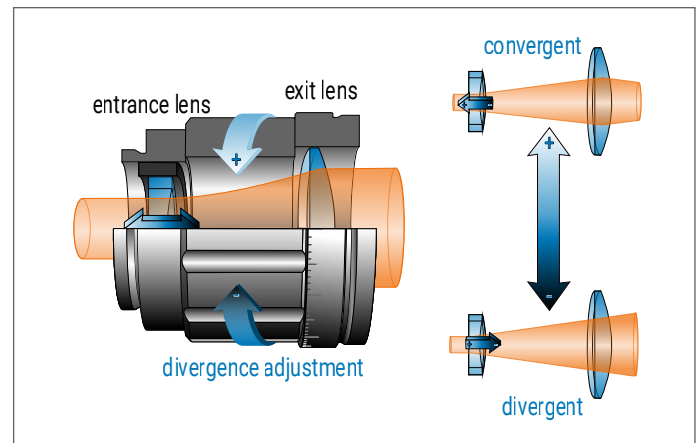
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DATA SHEET

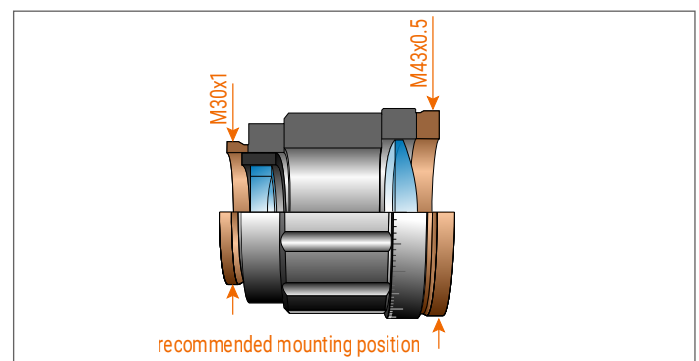
SPECIFICATIONS

article number	S6EXK0020-328
design wavelength [nm]	1064
magnification factor	2.0
divergence adjustable	yes
optical principle	Galilei (no internal focus)
pointing stability [mrad]	< 1
clear input aperture [mm]	12.0
clear output aperture [mm]	26.0
recommended beam-Ø [mm] ¹⁾	10.0
total number of lenses	2
total transmission [%]	> 99
lens material	fused silica
LIDT (coating) [J/cm ²]	5.0 J/cm ² per 1ns pulse at 50Hz
SP and USP usable	yes
SP and USP usable, reversed usage	yes
mounting thread	M30x1
weight [kg]	0.2
accessory	S6MEC0127 - adapter M30x1 to C-mount

DIVERGENCE ADJUSTMENT



MOUNTING POSITIONS



REMARKS

¹⁾clipped at $1/e^2$; wavefront error on axis (PV) < $\lambda/10$ (value provided by design)

magnification (reversed mode) = 1 / magnification (regular mode)

divergence adjustment = 0 → collimated input beam results in collimated output beam

maximum divergence adjustment is ± 3 mm

RoHS compliant

length at divergence setting „0“ stated in the drawing - length extension of max. 3 mm is possible

BACK REFLECTION POSITION

back reflections [mm]	
24.7	
back reflections reverse [mm]	
32.49	
0.00	
0.00	

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